



GP 2851

#21/G

12/00/00

XA-7889A Re

PATENT APPLICATION

gfr

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kenji NISHI

Appln. No.: 09/994,758

Group Art Unit: 2851

Filed: December 19, 1997

Examiner: A. Mathews

For: PROJECTION EXPOSURE APPARATUS

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SUPPLEMENTAL AMENDMENT

RECEIVED
DEC 11 2000
TECHNOLOGY CENTER 2800

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Supplementing the Amendment filed October 6, 2000,
please further amend the above-identified as indicated
below.

IN THE CLAIMS:

- 1 35. (Amended) A scanning exposure apparatus for
2 projecting a pattern image of a mask onto a sensitive plate
3 through a projection system having a predetermined
4 magnification ratio in a scanning manner, the apparatus
5 comprising:
6 (a) a scanning system which has a first driving system
7 to move the mask and a second driving system to move the
8 plate and which synchronously scans the mask and the plate

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